

<b>Notice of References Cited</b>	Application/Control No. 10/565,715		Applicant(s)/Patent Under Reexamination CHAVEZ ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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#### FOREIGN PATENT DOCUMENTS

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	N	JP 10277384 A	10-1998	Japan	SATO et al.	B01J 20/04
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#### NON-PATENT DOCUMENTS

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